Tel: +91-97429 72744 info@takshila-vlsi.com



MEMORANDUM OF UNDERSTANDING (MOU) FOR ACADEMIC COLLABORATION

Between



TAKSHILA INSTITUTE OF VLSI TECHNOLOGIES, BENGALURU, KARNATAKA

And



CHRIST THE KING ENGINEERING COLLEGE COIMBATORE - 641104, TAMILNADU

This MOU is entered onto on the 15th day of February 2023 by and between Takshila Institute of VLSI Technologies (hereafter called Takshila VLSI) situated at 2nd Floor, Ram Arcade, 90/1B, CKB Layout, Marathahalli, Bengaluru – 560037, Karnataka.

Regd. Office: 2nd Floor, Ram Arcade, 90/1B, CKB Layout, Chandra Layout, Marathahalli, Bengaluru, Karnataka 560037, INDIA | GSTIN: 29AAOFT6099G1ZC

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and

Christ the King Engineering College, (hereafter called College) situated at Coimbatore, Tamilnadu State

1. Objectives of MOU

- **a.** To promote and enhance semiconductor / VLSI domain interest in students.
- **b.** To provide Online/Offline/Weekend training to students in VLSI courses such as Physical Design / Analog Layout /ASIC Verification / Design For Test (DFT).
- c. To provide internship to students from VLSI Service provider company SiValley Technologies Pvt. Ltd. in Digital or Analog Domains.
- **d.** To provide placement assistance to the students who complete the course / internship.
- e. To provide academic interaction by delivering special lectures at college on topics of relevance to semiconductor domain

2. Proposed Modes of Collaboration

Takshila VLSI and College to collaborate through the following:

- a. Cooperation and promotion of education and training in areas of mutual interest.
- **b.** Any other appropriate mode of interaction agreed upon between Takshila VLSI & College.

Any specific plan will be worked out by the college depending upon availability of resources.

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3. Terms and Conditions

- **a.** For the visits related to advice & consultancy, travel and other expenses of Takshila VLSI staff shall be reimbursed by College on mutually agreed terms.
- b. Usage of College academic infrastructure can be allowed for limited period subject to its availability, approval of Head of the facility/ department and college norms.
- c. This MOU may be amended, renewed and terminated by mutual written agreement of the *colleges* at any time.
- **d.** Either Takshila VLSI or College shall have the right to terminate this MOU upon 60 days prior written notice to the other.

4. Confidentiality

The Takshila VLSI and the College agree to hold in confidence all information /data which is obtained from either *Takshila VLSI or College* or created during the performance of the MOU and will not disclose the same to any third party without written consent of the other.

5. Duration of MOU

This MOU, unless extended by mutual written consent of the *both*, shall expire in FIVE years after the effective date. However, on review, the MOU shall be extended for another TWO years by mutual consent.

6. Coordinators

Both Takshila VLSI and College will designate persons who will have responsibility for coordination and implementation of this agreement.



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7. Intellectual Property Rights

Intellectual Property Rights (IPR) that arise as a result of joint research and collaborative activity under the agreement will be worked out on a case to be case basis and will be consistent with officially laid down IPR polices both.

8. Signed in Duplicate

The MOU is executed in duplicate with each copy being an official version and having equal legal validity. By signing below, the *Takshila VLSI and College*, acting by their duly authorized officers, have caused this Memorandum of Understanding to be executed, effective as of the day and year first above written.

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|-------|--|-----------------------------|----------|
| | On behalf of | On behalf of | |
| | TAKSHILA INSTITUTE OF VLSI | CHRIST THE KING ENGINEERING | |
| | TECHNOLOGIES | COLLEGE | |
| | For Takshila Institute of VI-SI Technologies | ING ENG | INEED |
| | For Takshila Institute of VLSI Technologies | KARAN COUMB | AIUKE CI |
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| | Authorised Signatory Venkataswamy Nandam | Dr.M.Jeyakumar | 303// |
| | DIRECTOR | Principal | *// |
| | | | |
| | A. Koran Kumar | | |
| | Kiran Kumar Kaspa | Dr.V.Muralidharan | |
| | Operations Manager | Head of the Department/ECE | |
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| | Megha M GALURH A CEMENT COORDINATOR | Mr.V.Sureshbabu | |
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